

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

licant

: Jesse D. Wolfe et al

Docket No.: IL-11072

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: August 18, 2003

Examiner: Rodney G. McDonald

For

Process and Apparatus for Pulsed DC Matnetron Reactive Sputtering of Thin

Film Coatings on Large Substrates Using Smaller Sputter Cathodes

Commissioner for Patents Alexandria, VA 22313-1450

CERTIFICATE OF MAILING UNDER 37 CFR 1.8(a)

I hereby certify that the attached correspondence comprising:

1. Amendment (11 pages)

- 2. Petition and Fee for Extension of Time (dup) (2 pages)
- 3. Express Mail Certificate (1 page)
- 4. Postcard

is being deposited with the United States Postal Service as express mail in an envelope addressed to:

> Commissioner for Patents Alexandria, VA 22313-1450

Teresa Walls

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